



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4334**

Junichiro YOSHIOKA et al. : Docket No. 2001_1740

Serial No. 09/990,387 : Group Art Unit 1753

Filed November 23, 2001 : Examiner Arun S. Phasge

SEMICONDUCTOR WAFER HOLDER
AND ELECTROPLATING SYSTEM FOR
PLATING A SEMICONDUCTOR WAFER

Mail Stop: Amendment

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of March 24, 2005, the period for response having been extended for two (2) months by the attached petition, please amend the present application as follows:

Amendments to the Abstract

Kindly replace the original abstract with the attached substitute abstract.